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SEMICONDUCTOR CIRCUIT AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE

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Mail Stop Amendment Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

## AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

Applicants submit this Amendment for entry thereof in response to the Office

Action mailed January 12, 2007.

## CERTIFICATION OF ELECTRONIC TRANSMISSION

I hereby certify that this paper is being electronically transmitted to the Patent and Trademark Office on the date shown below.

Dated: April 12, 2007

J. Esatto Jr.